

Notice of References Cited		Application/Control No. 10/584,868	Applicant(s)/Patent Under Reexamination KIM ET AL.	
		Examiner Kriellion A. Sanders	Art Unit 1796	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,773,803	08-2004	Lee et al.	428/323
*	B	US-2004/0249012	12-2004	Tanaka et al.	522/083
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 11335596	12-1999	Japan		(Abstract Provided)
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Derwent Abstract ACC- No: 2000-092747, JP 11335596 , December 7, 1999, pp. 1-3.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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